

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/645,571	KWON ET AL.	
Examiner	Art Unit	
Yavier Szewai Wong	2616	

SEARCHED					
Class	Subclass	Date	Examiner		
370	328,335	7/6/2008	xsw		
	341,342	7/6/2008	XSW		
	431,441	7/6/2008	XSW		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
updated EAST search	7/6/2008	XSW		
consulted with SPE Rafael Perez- Gutierrez (class 455)	7/8/2008	XSW		
consulted with PE Gregory Sefcheck (class 370)	7/9/2008	XSW		
updated NPL search	7/3/2008	xsw		